



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Applicant: | CYRILLE et al. | Examiner: | Unassigned |
| Serial No.: | 10/633,765 | Group Art Unit: | 1742 |
| Filed: | August 4, 2003 | Docket No.: | HSJ920030027US1 (HITG.025US01) |
| Title: | METHOD FOR PROVIDING A LIFTOFF PROCESS USING A SINGLE LAYER RESIST AND CHEMICAL MECHANICAL POLISHING AND SENSOR FORMED THEREWITH | | |

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence and the papers, as described hereinabove, are being deposited in the United States Postal Service, as first class mail, in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on March 16, 2005.

By: Kathleen McDevitt
Kathleen McDevitt

STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Kindly advise the undersigned of the present status of this application, and please indicate when a communication from the U.S. Patent and Trademark Office may be expected.

Respectfully submitted,

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Date: March 15, 2005

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